

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application No.: 10/798,653
Applicants: Edmond BAILLOT, et al.
Filed: March 11, 2004
Title: Plasma cutting process with dual gas flow
TC/A.U.: 3742
Examiner: Mark H. Paschall
Docket No.: Serie 6150
Customer No.: 000040582

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of February 8, 2005, please amend the application as follows:

Amendments to the Specification begins on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begin on page 3 of this paper.

Remarks begin on page 7 of this paper.

An **Appendix** including an Abstract is attached following page 10 of this paper.

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